

10/538727

JC17 Rec'd PTO 13 JUN 2005
PATENT

Attorney Docket:
33082 M 256

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Hideo SHITE

International Application No.: PCT/JP2003/16154

International Filing Date: December 17, 2003

U.S. Serial No.: To Be Assigned

Group Art Unit: To Be Assigned

Filed: : Herewith

Examiner: To Be Assigned

For: COATING PROCESS APPARATUS AND
COATING FILM FORMING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

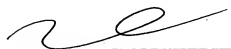
Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicant is enclosing an Information Disclosure Citation Form (PTO-1449) which lists the documents noted in the specification and International Search Report being filed herewith. Copies of all non-U.S. cited documents are enclosed.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,

SMITH, GAMBRELL & RUSSELL, LLP

By:


Michael A. Makuch, Reg. No. 32,263
1850 M Street, N.W., Suite 800
Washington, D.C. 20036
Telephone: (202) 263-4300
Fax: (202) 263-4329

June 13, 2005

234712

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /Y.T.T

JC17 Rec'd PCT/PTO 13 JUN 2005

FORM PTO-1449	ATTY. DOCKET 33082M256	SERIAL NO. 10538727
INFORMATION DISCLOSURE STATEMENT		
APPLICANT: Hideo Shite		
FILING DATE Herewith	GROUP ART UNIT To Be Assigned	

U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE, IF APPROPRIATE
	AA	2001/0028920	10/11/01	Ito et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						

FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO	
	AH	2001-189266	7/10/01	Japan			Abstract	
	AI	09-017722	1/17/97	Japan			Abstract	
	AJ	2002-110517	4/12/02	Japan				X
	AK	06-099125	4/12/94	Japan			Abstract	
	AL	64-039023	2/9/89	Japan			Abstract	
	AM							
	AN							
	AO							
	AP							

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	AQ	
	AR	
	AS	
	AT	
EXAMINER:	DATE CONSIDERED:	
/Yewebdar T Tadesse/		11/21/2008
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		